

INFORMATION DISCLOSURE STATEMENT

Case Name. Serial No.

Gasparyan 4-20-11-6 10/816569

Applicant: Filing Date:

S. Arney et al. April 1, 2004

Group:

April 1, 2004

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
all	AA	6,185,961	2/13/2001	Tonucci, et al.	- 65	60.4	1/27/1999
a	AB	US Pat. App. 10/798064		Amey, et al			3/11/2004
M	AC	US Pat. App. 10/806543		Arney, et al			3/23/2004
la	AD	US Pat. App. 10/816569		Gasparyan, et al.			4/1/2004
Ca .	AE	US Pat. App. 10/674448		Hodes, et al.			9/30/2003
all	AF	US Pat. App. 10/803565		Hodes, et al.			3/18/2004
A	AG	US Pat. App. 10/803641		Hodes, et al.			3/18/2004
(A	AH	US Pat. App. 10/403159		Komblit, et al.			3/31/2003
Cla	Al	US Pat. App. 10/649285		Kornblit, et al.			8/27/2003
a	AJ	US Pat. App. 10/716084		Kroupenkine, et al.			11/18/2003
ils.	AK	US Pat. App. 10/803576		Kroupenkine, et al.			3/18/2004
09	AL	US Pat. App. 10/810774		Kroupenkine, et al.			3/26/2004
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FOREIGN PATENT DOCUMENTS

	Document Number	.Date	Country	Class	Subclass	Translation

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

Ol	AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002).

^{***}References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

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		11/27/01/
		11/4/104

^{***}Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

A. Gasparyan 4-20-11-6

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